INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 19, 2026

IGI Report Number	LG838619016
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OCTAGONAL MIXED CUT
Measurements	5.90 X 5.90 X 3.83 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	G
Clarity Grade	VS 2

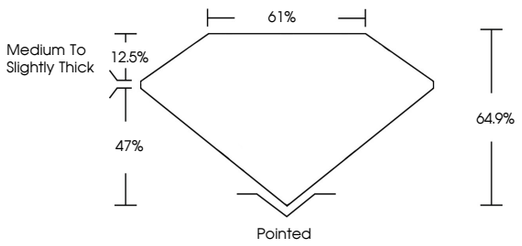
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG838619016

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG838619016
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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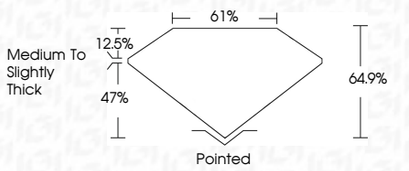
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IGI Report No LG838619016
OCTAGONAL MIXED CUT
5.90 X 5.90 X 3.83 MM
Carat Weight 1.01 CARAT
Color Grade G
Clarity Grade VS 2
Depth 64.9%
Table 61%
Girdle Medium To Slightly Thick
Culet Pointed
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG838619016
Comments:
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Type IIa